



Patent
Attorney's Docket No. 015290-500

UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
S. Y. LI et al.) Group Art Unit: 1763
Application No.: 09/820,695) Examiner: A. W. Olsen
Filed: March 30, 2001) Confirmation No.: 4162
For: METHOD OF PLASMA ETCHING)
LOW-K DIELECTRIC MATERIALS)
)
)

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action mailed September 27, 2005, please amend
the above-identified patent application as follows:

12/08/2005 JADD01 00000019 09820695
01 FC:1202 50.00 OP